# Phosphorus solid solution effects of electric and dielectric properties on sintered WO<sub>3</sub> ceramics

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Phosphorus solid-soluted WO<sub>3</sub> ceramics ( $P_xW_{1-x}O_3$ ) were fabricated by a solid state reaction at 1000°C for 100 h with the phosphorus concentration x of 0 to 0.3. Phosphorus-doped single-phase monoclinic WO<sub>3</sub> ceramics were fabricated with phosphorus concentration between 0 and 0.3. Sintered WO<sub>3</sub> pellets that were P-doped with phosphorus concentrations of 0–0.3 were synthesized at 1000°C in 24 h in order to evaluate electric and dielectric properties. The resistivity of specimens decreased concomitantly with increasing the stoichiometry x in  $P_xW_{1-x}O_3$  from 0 to 0.15, and that increased with increasing phosphorus concentration, and the dielectric constant of the  $P_{0.05}W_{0.95}O_3$  and  $P_{0.10}W_{0.90}O_3$  were 2100 and 1400 at 100 kHz at room temperature, respectively. @2011 The Ceramic Society of Japan. All rights reserved.

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### 1. Introduction

Monoclinic tungsten trioxide (WO<sub>3</sub>) shows a high dielectric constant,<sup>1)-4)</sup> making WO<sub>3</sub> ceramic a candidate for use in ceramic capacitors. However, WO<sub>3</sub> resistivity is not high because oxygen defects exist in WO<sub>3</sub>, producing electron carriers in WO<sub>3</sub>.<sup>5),6)</sup> Consequently, it is difficult to use WO<sub>3</sub> as a ceramic capacitor material.

A previous report describes a phosphorus-doped tungsten complex oxide ceramic  $(ZrW_2O_8-Zr2WP_2O_{12})$ ,<sup>7)</sup> suggesting that phosphorus is substitutable for tungsten in a tungsten-based host structure. For WO<sub>3</sub>, the valence of tungsten is six; if oxygen defects exist in WO<sub>3</sub>, then the valences of tungsten are mixture of five and six, thereby; electron carriers are present in WO<sub>3</sub> ceramics. The phosphorus valence in phosphates or complex oxides is five. For that reason, it is assumed that the valence of the phosphorus in a complex oxide P–WO<sub>3</sub> is five. For this solid-solution P–WO<sub>3</sub> oxide, a phosphorus solid soluted in WO<sub>3</sub> might cause compensation of the electron carrier in WO<sub>3</sub> generated by oxygen defects, which is expected to increase the resistivity of a WO<sub>3</sub> host ceramic. That increased resistivity of WO<sub>3</sub> host ceramic enables evaluation of the dielectric properties of WO<sub>3</sub>.

In this investigation, phosphorus-doped WO<sub>3</sub> ceramics were fabricated by a traditional solid state reaction, with the stoichiometry *x* in  $P_xW_{1-x}O_3$  between 0 and 0.3. Furthermore, the resistivity and dielectric property of the  $P_xW_{1-x}O_3$  ceramics were evaluated at room temperature.

#### 2. Experimental procedure

The starting materials were  $WO_3$  (Wako Pure Chemical Industries, Ltd., Japan) and  $(NH_4)_2HPO_4$  (Wako Pure Chemical Industries, Ltd., Japan) powders. These powders were mixed with

the stoichiometry x in  $P_xW_{1-x}O_3$  between 0 (no mixed) to 0.3. Hereinafter,  $P_xW_{1-x}O_3$  means the x mol % solid solution of P in WO<sub>3</sub>. The mixture was die-pressed to produce a pellet. The pellet was calcined at 1000°C for 2–100 h in air. It was then ground; the powder was die-pressed again using uniaxial pressing. The pellet was sintered at 1000°C for 24 h. Thereby; a phosphorus solid-soluted WO<sub>3</sub> specimen was synthesized.

The crystal structure of the specimens was determined using X-ray diffraction (XRD, Miniflex-II; Rigaku Corp.) at room temperature with Cu K $\alpha$ . The microstructural observation and the elementary analysis of the sample were done using scanning electron microscopy (SEM, S-3200N; Hitachi Ltd.) and energy dispersive X-ray analysis (EDX, EMAX-3000; Horiba Ltd.). The resistivity of the specimens was evaluated using a two-probe method with a digital voltmeter (34405A; Agilent Technologies Inc.) and a power supply (3640A; Agilent Technologies Inc.). Dielectric measurements were performed using an LCR meter (HP 4284A; Hewlett-Packard Inc.). All electrical measurements were conducted at room temperature.

## Results and discussion

Ten % Phosphorus mixed WO<sub>3</sub> ( $P_{0.1}W_{0.9}O_3$ ) samples were heat-treated at 1000°C for 2–100 h. **Figure 1** shows XRD patterns for the  $P_{0.1}W_{0.9}O_3$  ceramics under various heat-treatment times. For specimens heat-treated less than 35 h, a WO<sub>3</sub> monoclinic structure (JCPDS 72-1465) was observed as a main phase, with a secondary phase [ $W_2O_3(PO_4)_2$ , JCPDS 76-1687]. However, for specimens heat-treated over 65 h, the XRD peaks of the specimens were assigned as a monoclinic WO<sub>3</sub> single phase; no  $W_2O_3(PO_4)_2$  peak was observed.

**Figure 2** presents the SEM images and the elemental mapping images for phosphorus and tungsten of the  $P_{0.1}W_{0.9}O_3$  ceramic heat-treated at 1000°C for (a) 35 h and (b) 100 h. For the specimen that was heat-treated for 35 h, the elemental positions between phosphorus and tungsten almost fit each other. However,

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those of the grain boundary and at the grain surface were not fitted. Therefore, the reaction did not occur completely between  $WO_3$  and phosphorus at 1000°C for 35 h. For the specimen heat-treated for 100 h, the elemental positions of phosphorus and tungsten mutually coincided, and the reaction between phosphorus and  $WO_3$  proceeded completely at 1000°C for 100 h.

Results of XRD and the SEM-EDX measurements proved that the reaction time of phosphorus and  $WO_3$  must be longer than 65 h, and that the reaction occurred sufficiently more than the



Fig. 1. XRD patterns for 10% phosphorus-doped WO\_3 specimens heat-treated at 1000°C for 2–100 h.

heat-treatment time of 100 h. In this investigation, the specimens were heat-treated at 1000°C for 100 h.

The  $P_x W_{1-x} O_3$  (x = 0-0.3) powders were reacted at 1000°C for 100 h. **Figure 3** shows XRD patterns for resulting specimens. All the samples with phosphorus contents x in  $P_x W_{1-x} O_3$  between 0 and 0.3 were assigned as a monoclinic WO<sub>3</sub> single phase, and the another phases were not observed for all the



Fig. 3. XRD patterns for the *x* in  $P_xW_{1-x}O_3$  of 0–0.3 specimens heat-treated at 1000°C for 100 h.



Fig. 2. (Color online) SEM-EDX images of the 10% phosphorus WO<sub>3</sub> specimens heat-treated at  $1000^{\circ}$ C for (a) 35 and (b) 100 h.



Fig. 4. An SEM image of the sintered  $P_{0.1}W_{0.9}O_3$  specimen heat-treated at 1000°C for 24 h.



Fig. 5. Resistivity of the resulting  $P_x W_{1-x} O_3$  (x = 0-0.3) specimens at room temperature.

specimens. These results suggest that the above heat-treatment condition was sufficient to be reacted phosphorus to  $WO_3$  host material.

Using these powders,  $P_x W_{1-x} O_3$  (x = 0-0.3) pellets were fabricated at 1000°C for 24 h; the resulting ceramics with whiteyellow color were used for measurements of electrical properties. **Figure 4** shows the SEM image of a sintered  $P_{0.10} W_{0.90} O_3$  pellet as a representative sample. From the SEM image, the resulting specimen was sufficiently sintered on the sintering condition, and the other samples were sintered under same sintering condition.

Resistivity of the resulting  $P_x W_{1-x} O_3$  sintered pellets was evaluated using a two-probe method. Figure 5 portrays data showing the electrical resistivity of the specimens as a function of the phosphorus concentration in WO<sub>3</sub>. Resistivity of the nondoped WO<sub>3</sub> ceramic was  $5.4 \times 10^3 \Omega$  cm. That of P<sub>x</sub>W<sub>1-x</sub>O<sub>3</sub> ceramics increased concomitantly with increased phosphorus concentration x of 0 to 0.15. The resistivity increased with increasing the phosphorus concentration x larger than 0.15, and the resistivity of the P<sub>0.3</sub>W<sub>0.7</sub>O<sub>3</sub> was close to the non-doped WO<sub>3</sub> ceramic. The resistivity of the resulting specimens with the  $P_{0.10}W_{0.90}O_3$ ,  $P_{0.15}W_{0.85}O_3$  was  $2.9 \times 10^5$ ,  $7.3 \times 10^5 \Omega$  cm, respectively. These values were 2 orders larger than that of the non-doped WO<sub>3</sub> ceramic. Phosphorus, with a valence number of five, was doped into the WO<sub>3</sub> host structure as the valence number of 6. Therefore, it assumed that the electron carrier as oxygen defect in WO<sub>3</sub> was neutralized by a solid solution of phosphorus in a WO<sub>3</sub> host.

**Figure 6** presents dielectric properties of the WO<sub>3</sub> ceramics with phosphorus concentrations x of 0, 0.05, 0.10, and 0.15. Where, the dielectric constants of the other specimens were not evaluated because of their large dielectric losses. The dielectric loss of the non-doped WO<sub>3</sub> specimen was very large between



Fig. 6. Dielectric constant and loss of the  $P_xW_{1-x}O_3$  specimens: (a) x = 0, (b) x = 0.05, (c) x = 0.10 and (d) x = 0.15.

l kHz to 1 MHz, and the values were larger than 0.5. Therefore, it assumed that the dielectric constant of the non-doped WO<sub>3</sub> could not be evaluated. At 1 kHz, the dielectric loss of these specimens was very large, close to 1, and the loss was less than 0.1 at frequencies higher than a few tens of kHz. The dielectric constants of the  $P_{0.05}W_{0.95}O_3$ ,  $P_{0.10}W_{0.90}O_3$ ,  $P_{0.15}W_{0.85}O_3$  were 2100, 1400 and 150 at 100 kHz. Increasing the phosphorus contents in the WO<sub>3</sub> caused decreasing the dielectric constant of the specimens. Generally, dielectric constant depends on the electron density of the materials. The electron density of the phosphorus is much smaller than that of tungsten. In this article, phosphorus was substituted to the tungsten site in the WO<sub>3</sub> host structure. Therefore, it assumed that increasing the phosphorus contents in the WO<sub>3</sub> caused decreasing the dielectric constant of the specimens.

Hirose et al. reported that the dielectric constant of the nondoped WO<sub>3</sub> ceramic was 4000 at  $16.2^{\circ}C$ ,<sup>4)</sup> and those of the phosphorus-doped WO<sub>3</sub> ceramic was smaller than the value reported for non-doped WO<sub>3</sub> at 100 kHz. Therefore, it assumed that the doping phosphorus in WO<sub>3</sub> host caused decreasing the dielectric constant of WO<sub>3</sub>.

## 4. Conclusion

Phosphorus-doped WO<sub>3</sub> ceramic was fabricated at 1000°C for 100 h with phosphorus concentrations between 0 to 30%. Resistivity of the resulting specimens of  $P_{0.10}W_{0.90}O_3$ ,  $P_{0.15}W_{0.85}O_3$  was 2 orders larger than that of the non-doped WO<sub>3</sub> ceramic. Oxygen defects acting as electron carriers in WO<sub>3</sub> were neutralized by a solid solution of phosphorus in WO<sub>3</sub>, proving that the electrical insulation of WO<sub>3</sub> host ceramics is controllable by phosphorus doping of WO<sub>3</sub>. The dielectric constants of  $P_x W_{1-x}O_3$  decreased with increase of the phosphorus contents in WO<sub>3</sub> host ceramics.

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